# Alternative Method for Large Vacuum Systems



CE/ET BEAMTUBE WORKSHOP III 2025

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#### **Outline**

- Intro TNO
- Gravitational waves
- Einstein Telescope and cosmic explorer
- ET MacBeth project
- An alternative method for large vacuum systems bake-out
- Conclusions and outlook



TNO – Semicon Equipment groups

TNO: Netherlands Organisation for Applied Scientific Research

Established in 1932, non-profit organisation

Independent and confidential partner

• 2024: ~4500 employees, ~764 MEUR organisation revenue





Campus TU-Delft, Delft

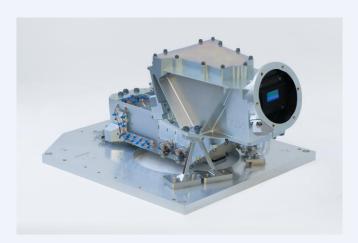
Eindhoven

Groningen

#### **TNO High Tech Industry**









#### APPLICATIONS

## First MetOp-SG and Sentinel-5 launched

13/08/2025 6688 VIEWS 50 LIKES

ESA / Applications / Observing the Earth / Meteorological missions / MetOp Second Generation

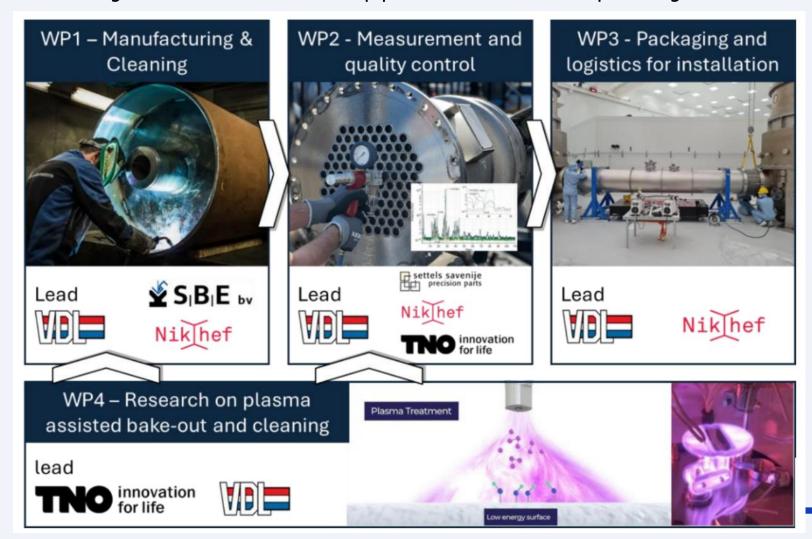
Ushering in a new era of weather and climate monitoring from polar orbit, the first in a new series of satellites, MetOp Second Generation, has been lofted into orbit aboard an Ariane 6 rocket from the European spaceport in Kourou, French Guiana. As part of this new satellite's sophisticated instrument package is the new Copernicus Sentinel-5 instrument, which is designed to deliver critical data on air pollutants, ozone and climate-related gases.

Lifting off on 13 August at 02:37 CEST (12 August 21:37 local time), the Ariane 6 rocket carried the four-tonne satellite into orbit around Earth. Confirmation that MetOp-SG-A1 was alive and well came at 04:47 CEST, after its solar array had been deployed, ensuring that the satellite could generate power.



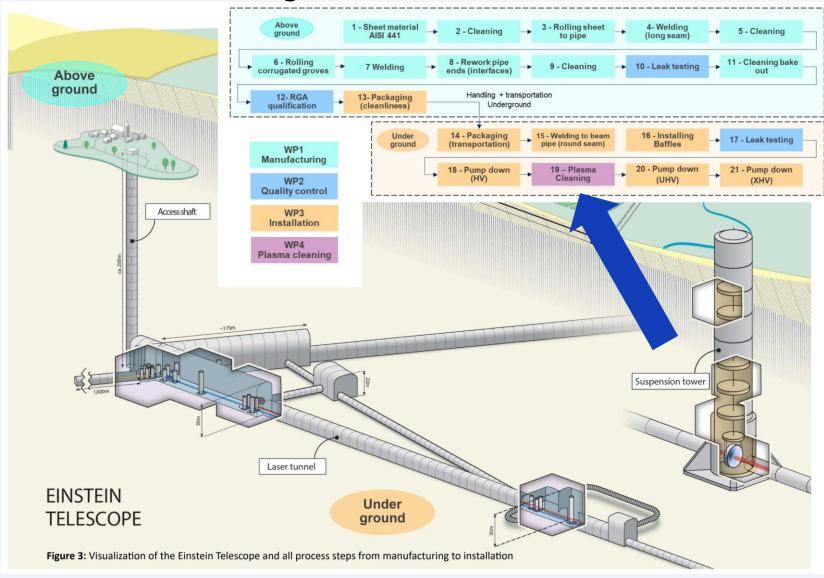
#### **MacBeth Project**

• Manufacturing and Cleanliness of Beampipe for Einstein Telescope in High-vacuum





#### **MacBeth Project**



- Design and make pilot section of a corrugated beam-pipe
- Study:
  - How to do industrial scale with the required cleanliness levels
  - How to measure the cleanliness levels and the quality also at the industrial scale



#### Alternative method for large vacuum systems bake-out

- The challenge; <u>surface absorbed water</u>
- Current intended method for the Einstein Telescope
  - Joule heating with thermal insulation
  - 5 km at a time, re-use of thermal insulation

CONF-881002--14

Proc. 35th National Symposium & Topical Conf. of the American Vac. Soc., Atlanta, GA, 10/3-7/88.

BNL-41181

OUTGASSING AND DESCRPTION OF THE STAINLESS STEEL BEAVER TUBES AFTER DIFFERENT DEGASSING TREATMENTS\*

BNL--41181

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Abstract

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#### VACUUM-PLASMA PROPERTIES OF STAINLESS STEEL AFTER IMPACT OF COMBINED GLOW-MICROWAVE DISCHARGES IN ARGON ATMOSPHERE

G.P. Glazunov, V.E. Moiseenko, S.M. Maznichenko, M.N. Bondarenko, A.L. Konotopskiy, I.K. Tarasov, A.N. Shapoval

Institute of Plasma Physics, National Science Center "Kharkov Institute of Physics and Technology", Kharkiv, Ukraine E-mail: glazunov@ipp.kharkov.ua case it is a copper sheet with dimensions 5×20 cm, then intense copper lines appear in the spectrum (Fig. 15,b). As the working gas pressure increases (the pumping is only with fore pump), intense lines characteristic of water (OH) are detected in the spectra (Fig. 16), which is apparently due to the insufficient speed of the fore vacuum pumping of impurities. Note, the intensity of OH signal in combined discharges is higher than that for GD. It could say about more effective surfaces treatment with combined discharges. Over time, during discharge cleaning, the intensity of the water lines decreases (see Fig. 16,b) which is indication of the wall conditions improvement.

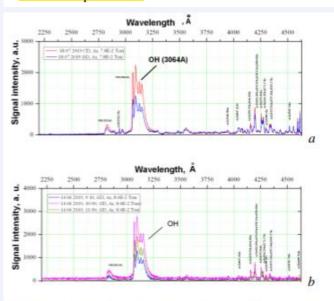


Fig. 16. Emission plasma spectra of glow and combined discharges during evacuation of the chamber by a fore pump (a); spectra of glow discharges vs a cleaning time



### **More literature**

	Cleaning of Silicon Wafer Surfaces with Reactive Gases.pdf
$\circ$	Combined RF-DCP_plasma Discharge Cleaning.pdf
	CONDITIONING VACUUM Chambers.pdf
	DC Glow Discharge Between Coaxial Cylinders .pdf
	DC Glow Discharge Between Coaxial Cylinders 2.pdf
	DC Glow Discharge COMSOL.pdf
	DC Glow Discharge.pdf
	DC Glow Discharge2.pdf
	DC Glow Discharge3.pdf
	DC Glow Discharge4.pdf
	DC Glow Discharge5.pdf
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	N11_sab99comparison.pdf
	N13_1-s2.0-S009457651731562X-main.pdf
	N14_19810013548.pdf
	N3_S1063780X23600433.pdf
	N4_Probe Diagnostics of Plasma Parameters in a Large-Volume Glow Discharge
	N5_UPAP4810723-730.pdf
	N6_3_Basu Ghimre_KUSET_August3_2014_edited.pdf.crdownload

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		20250407_Vessel Pump Down Calculation.pdf	1.0
		6. A new method for determining water adsorption phenomena on metal surface in a value of the contraction	1.0
		$A\_new\_model\_for\_vacuum\_quality\_and\_lifetime\_predic.pdf$	1.0
		Cern_School_2006_Thermal_outgassing.pdf	1.0
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	X	SorptionIsothermSS.xlsx	1.0
		SorptionIsothermWaterSS.pdf	1.0
		TemkinIsotherm.pdf	1.0
		Thermal_outgassing_rates_of_low-carbon_steels.pdf	1.0
		VacCalculations.xmcd	1.0
		Water_outgassing_and_adsorption_isotherms_CScarcia.pdf	1.0

## Setup design considerations

- Diameter-to-length ratio
- Vacuum levels
- Plasma generation
- Costs

Gas	Max pressure [mbar]
H <sub>2</sub>	6.0 x 10 <sup>-11</sup>
CH <sub>4</sub>	2.2 x 10 <sup>-12</sup>
H <sub>2</sub> O	2.6 x 10 <sup>-13</sup>
со	2.9 x 10 <sup>-12</sup>
CO <sub>2</sub>	1.3 x 10 <sup>-12</sup>

**Tab. 8**; Maximum ultimate partial pressures in the ET beam pipe after a 7-day bakeout at 150°C, following the layout presented in section 6.3.3. The ultimate pressures reported should be regarded as upper limits.

Vacuum chamber

Plasma

Gas control

RGA

Safety

Pumps

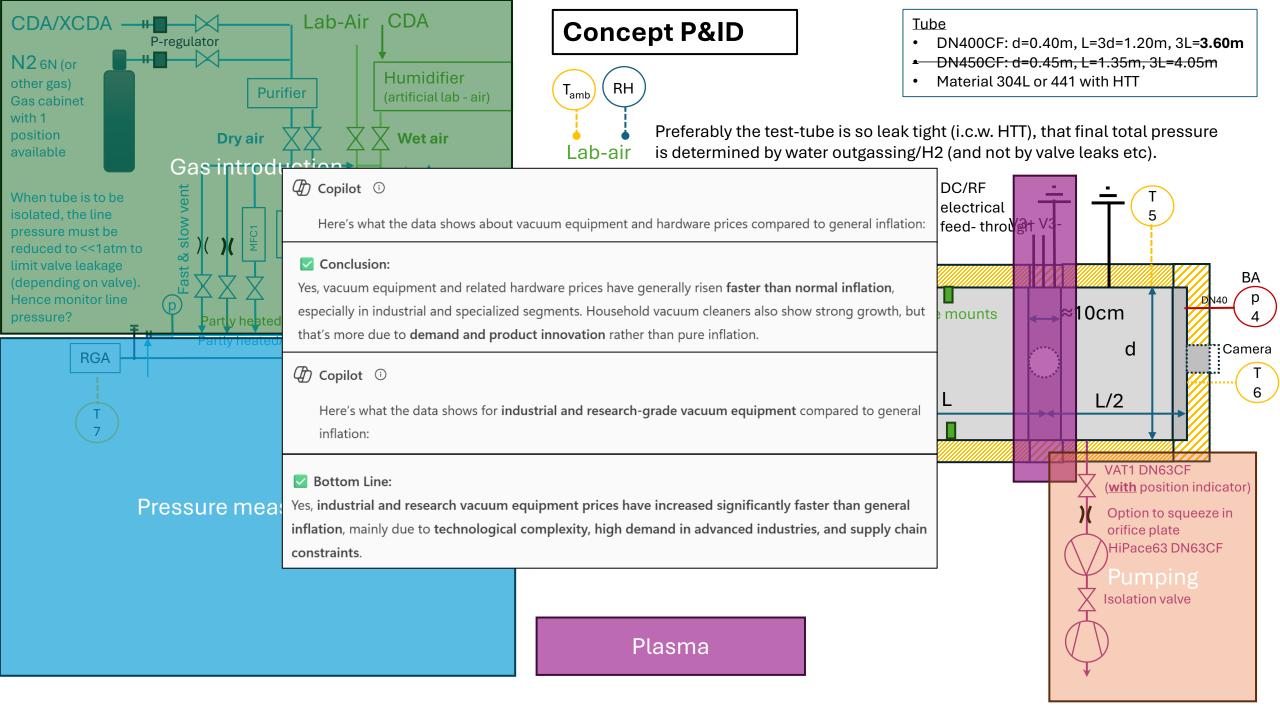
Pressure sensors

Bake-out

Plasma source Plasma head Recondition of wall

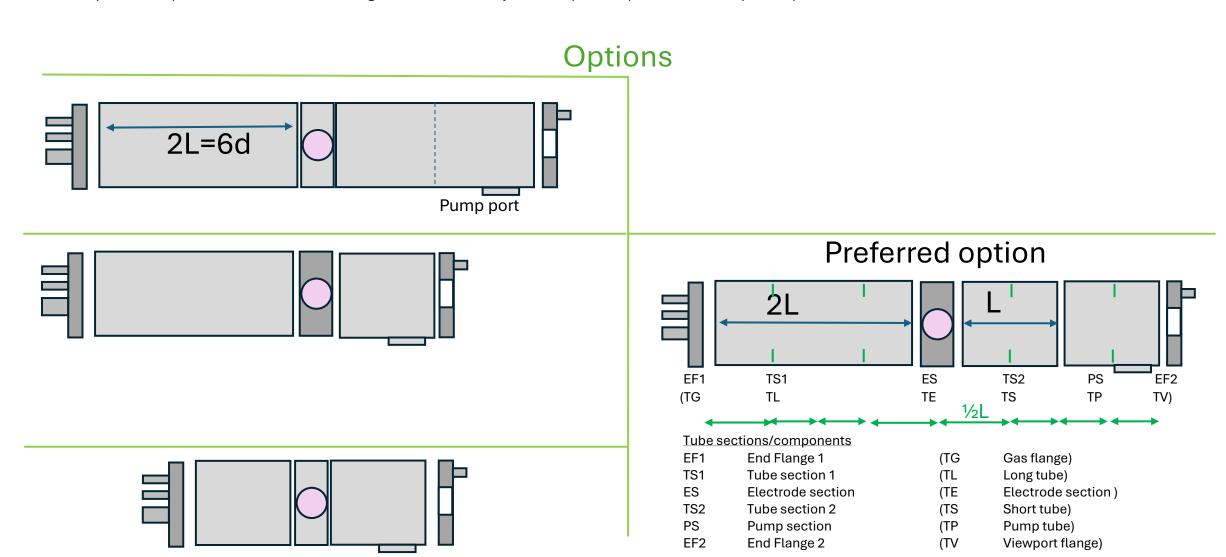
Control system





#### Reduced test tube configuration to drastically cut back on HW costs (02-04-2025)

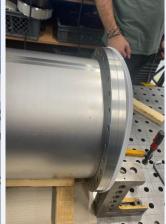
- Introduce zero length viewports & electrode feedthroughs
- Reduce tube diameter 400mm→300mm
- One electrode section (extent plasma tested by varying the tube length)
- Inner diameter d=0.3m, section length (L=3d=0.9m) 2L=6d=1.8m, 4L=3.6m
- Tube sections separately bakeable
- With preferred option we can realize tube length 2L and 4L with symmetric plasma (thus test extent plasma)



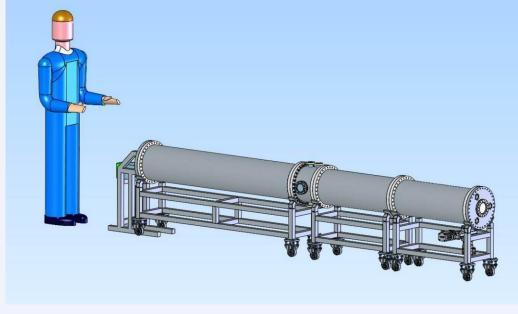
#### Vacuum chamber

- Vacuum fired AISI 304, cold rolled 2B finish
- Total length 3,6 meters (excluding frame)
- 3 configurations possible
  - Need to validate efficiency of plasma at varies distances from plasma source





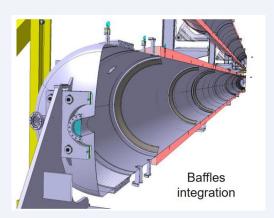


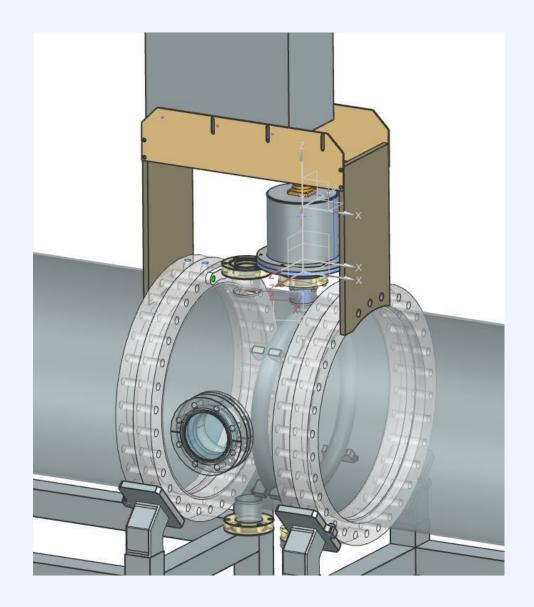




#### **Plasma**

- Long list of 10 plasma "types"
- Selected
  - RF 13,56 Mhz
  - DC Plasma
  - Or combined
- Shape of plasma antenna will ensure it will stay out of the beam path





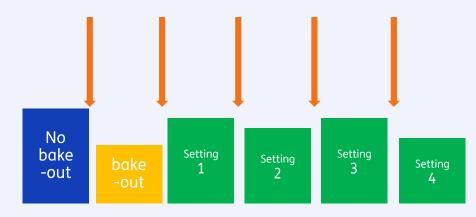


#### **Experimental plan**

- Total project has two experimental phases
  - "fundamental"
  - "towards Einstein Telescope"
- During the fundamental phase we look at parameters like
  - Pressure
  - Plasma source
  - Plasma settings per source
  - Process gas? (default is N2)
- Efficiency of a setting is compared to 1 week bake-out @150°C
- During the "towards Einstein Telescope" phase we start limiting the parameter scope and

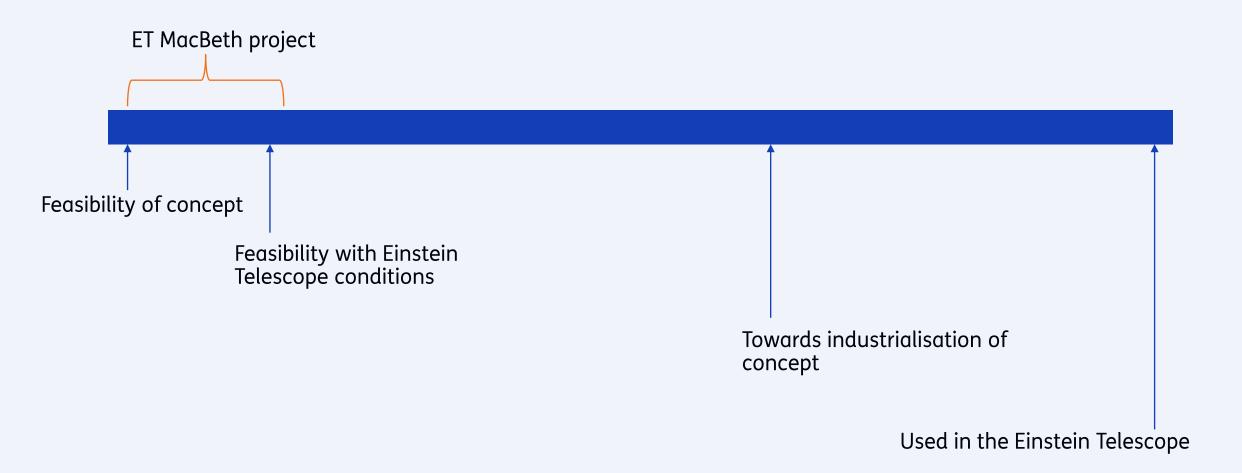
"no limits"

Increase measurement accuracy





#### Time-line





#### **Outlook and conclusion**

- Hardware is currently arriving (wk43 vacuum vessel)
- Installation is ongoing
- Validation of total setup to start in Oktober 2025
- Experimental risk
  - Cleaning efficiency of surfaces far away from plasma source
- "High risk, high gain" project
  - Fits well with the "yet to be invented technology" statement that is commonly used within the Einstein Telescope community
- A lot of experimental work ahead of us



# Thank you for your attention Acknowledgement

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